

Netherlands-Utrecht: Laboratory, optical and precision equipments (excl. glasses)

OJ S 50/2014 12/03/2014

Contract award notice

Supplies

Directive 2004/18/EC

## Section I: Contracting authority

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### I.1. Name and addresses

Official name: Stichting voor Fundamenteel Onderzoek der Materie

National registration number: 111590197

Postal address: Van Vollenhovenlaan 659, AMOLF (science park 104, 1098 XG Amsterdam)

Town: Utrecht

Postal code: 3527JP

Country: Netherlands

For the attention of: Bart van Leijen

E-mail: [leijen@amolf.nl](mailto:leijen@amolf.nl)

Telephone: +31 207547100

Fax: +31 207547291

#### Internet address(es):

General address of the contracting authority: [www.amolf.nl](http://www.amolf.nl)

Electronic access to information: <https://www.tenderned.nl:443/tenderned-web/aankondiging/detail/samenvatting.xhtml?aankondigingId=31391>

### I.2. Type of the contracting authority

Body governed by public law

### I.3. Main activity

Other: Onderzoek

### I.4. Contract award on behalf of other contracting authorities

The contracting authority is purchasing on behalf of other contracting authorities: no

## Section II: Object of the contract

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### II.1. Description

#### II.1.1. Title

Inductively Coupled Plasma etching equipment.

#### II.1.2. Type of contract and place of performance or delivery

Supplies

Purchase

Main site or place of performance: Nederland.

NUTS code NL Nederland

#### II.1.3. Information about a framework agreement or a dynamic purchasing system (DPS)

#### II.1.4. Short description of the contract or purchase(s)

Delivery of a Inductively Coupled Plasma etching equipment.

**II.1.5. CPV code(s)**

38000000 Laboratory, optical and precision equipments (excl. glasses)

**II.1.6. Information about the Government Procurement Agreement (GPA)**

The procurement is covered by the Government Procurement Agreement: yes

**II.2. Total value of the contract/lot****II.2.1. Total value of the contract/lot****Section IV: Procedure**

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**IV.1. Type of procedure****IV.1.1. Type of procedure**

Open

**IV.2. Award criteria****IV.2.1. Award criteria**

The most economically advantageous tender in terms of

1. Price the lowest total price of the Tender The price evaluation will take place with regard to the following elements: - Purchase price - Factory Acceptance Tests of Descriptive Document. - Documentation as described in Descriptive Document. - Delivery DDP (cf. Incoterms 2010). Weighting 40

2. Quality 1. Process specifications 2. System Software 3. Reaction Chamber 4. Load lock and transfer chamber 5. RIE source and RF generator 6. ICP source and RF generator 7. End point detection 8. Reactor chamber vacuum 9. Safety Features 10. Experience with process application. Weighting 60

**IV.2.2. Information about electronic auction**

An electronic auction has been used: no

**IV.3. Administrative information****IV.3.1. File reference number attributed by the contracting authority**

59000

**IV.3.2. Previous publication concerning this procedure****Contract notice**

Notice number in the OJ S: [2013/S 70-116378](#) of 10.4.2013

**Section V: Award of contract**

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Contract No: 1

Lot title: Inductively Coupled Plasma etching equipment

**V.1. Date of conclusion of the contract**

21.6.2013

**V.2. Information about tenders**

Number of tenders received: 1

**V.3. Name and address of the contractor**

Official name: Oxford Instruments Plasma Technology  
Postal address: tubney Woods Abington 15 15  
Town: Abington  
Postal code: OX13  
Country: Netherlands

**V.4. Information on value of the contract/lot**

Initial estimated total value of the contract/lot:  
Value: 400 000 EUR  
excluding VAT

**V.5. Information about subcontracting**

The contract is likely to be subcontracted: no

**Section VI: Complementary information**

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**VI.1. Information about European Union funds**

The procurement is related to a project and/or programme financed by European Union funds:  
no

**VI.2. Additional information**

**VI.3. Procedures for review**

**VI.3.1. Review body**

**VI.3.2. Review procedure**

**VI.3.3. Service from which information about the review procedure may be obtained**

**VI.4. Date of dispatch of this notice**

7.3.2014